

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/598,502 Confirmation No. 6549
Applicant : Yuichiro Nakamura et al.
371 Filed : September 1, 2006
Art Unit : 1733
Examiner : Mark L. Shevin
Customer No. : 00270
Title : SPUTTERING TARGET WITH FEW SURFACE DEFECTS,
AND SURFACE PROCESSING METHOD THEREOF

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL

Sir:

This is an "Amendment After Final" submitted within two months of a FINAL Office Action dated November 19, 2010. No new issues are raised. Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.